

Docket No.: GR 95 P 3487

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : ANWER PUTHAWALA ET AL.

Filed : Concurrently herewith

Title : APPARATUS FOR ADMITTING GAS INTO THE PRIMARY
COOLANT OF A PRESSURIZED WATER REACTOR

JC523 U.S. PTO
09/050651
03/30/98

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or
publications are submitted herewith:

U.S. Patent No. 3,975,170 (Keating, Jr.), dated August 17, 1976;

German Published, Non-Prosecuted Application No. 28 28 153 (Deinlein et al.),
dated January 3, 1980, as mentioned on page 2 of the specification;

German Patent No. 29 48 297 C2 (Schick et al.), dated January 17, 1985, as
mentioned on page 3 of the specification;

Published European Patent Application No. 0 328 408 A2 (Head et al.), dated
August 16, 1989;

French Patent Application No. 2 407 554, dated May 25, 1979, as mentioned on
page 4 of the specification and

"Chemische Konditionierung des Primär- und des Sekundärkreislaufes von
Druckwasserreaktoren", R. Rieß, VGB-Speisewassertagung 1972, pp. 14-21,

pertains to chemical conditioning of the primary and secondary cycle of pressurized water reactors.

If no translation of pertinent portions of any foreign language patents or publications mentioned above is included with the aforementioned copies of those applications, patents and/or publications, it is because no existing translation is readily available to the applicant.

Respectfully submitted,



For Applicants

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Date: March 30, 1998

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